

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

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EXAMINER
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**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO 500.41295X00
TITLE : Plasma processing method and apparatus			
U.S.DEP'T. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claims for O.G.
Assistant Examiner		DRAWING	
		Sheets Drawn	Fig.s Drawn
			Print Fig.
Primary Examiner			
		Application Examiner	
TERMINAL		PREPARED FOR ISSUE	
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